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Substitute for form 1449/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

| | | | |
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| Sheet | 1 | of | 3 |
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Complete if Known

| | |
|------------------------|-------------------|
| Application Number | 10,780,172 |
| Filing Date | February 16, 2004 |
| First Named Inventor | David H. Stark |
| Art Unit | To Be Assigned |
| Examiner Name | To Be Assigned |
| Attorney Docket Number | STRK-26,621 |

U. S. PATENT DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
|--------------------|-----------------------|--|--------------------------------|--|---|
| | | Number-Kind Code ² (if known) | | | |
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| | 19 | US- | | | |

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| Examiner Signature | HUNG VAN DUONG | Date Considered | 9/21/04 |
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

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| | | Examiner Name | To Be Assigned |
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| NON PATENT LITERATURE DOCUMENTS | | | |
|---|-----------------------|--|----------------|
| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
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| Examiner Signature | HUNG VAN DUONG | Date Considered | 9/21/04 |
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